



Our Docket No.: 42390P6459

RESPONSE UNDER 37 C.F.R. § 1.116  
-- EXPEDITED PROCEDURE --  
EXAMINING GROUP 2800

#13/Amend C  
(NES)  
8/3/02  
RECEIVED  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Chiang et al.

Examiner: Malsawma, L.

Serial No: 09/191,930

Art Unit: 2825

Filed: November 13, 1998

For: In-Plane On-Chip  
Decoupling Capacitors and  
Method For Making Same

**RESPONSE AFTER FINAL**

Box AF  
Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Final Office Action mailed on May 8, 2002, the Applicants respectfully request the Examiner to enter the following amendments and to consider the following remarks.

**FIRST CLASS CERTIFICATE OF MAILING**

I hereby certify that I am causing the above-referenced correspondence to be deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and that this paper or fee has been addressed to the Assistant Commissioner for Patents, Washington, D. C. 20231

July 8, 2002

Date of Deposit

Debbie Peloquin

Name of Person Mailing

*Debbie Peloquin*

Signature

July 8, 2002

Date